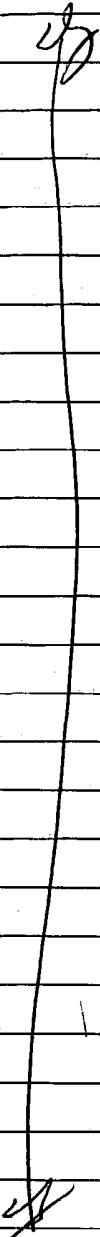
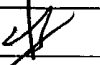
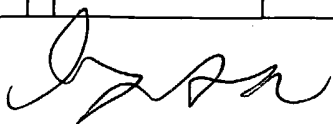
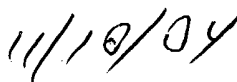


Atty. Docket No.: 00014DIV (3600-267-02)			Application No.:		Unassigned		
Applicant:		RAO, deceased, <i>et al.</i>					
Filing Date:			Group Art Unit:		Unassigned		
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial*	Document Number	Date	Name	Class	Sub Class	Filing Date If Appropriate	
	RE 32,260	10/07/1986	Fry	75	230		
	3,427,132	02/11/1969	Goon	23	204		
	3,723,838	03/27/1973	Kumagai	317	258		
	4,423,004	12/27/1983	Ross	419	35		
	4,544,403	10/01/1985	Schiele et al.	75	0.5 AB		
	4,805,074	02/14/1989	Harakawa et al.	361	525		
	4,954,169	09/04/1990	Behrens	75	228		
	4,968,481	11/06/1990	Rerat	419	23		
	5,211,741	05/18/1993	Fife	75	255		
	5,245,514	09/14/1993	Fife et al.	361	529		
	5,314,675	05/24/1994	Dubots et al.	424	344		
	5,412,533	05/02/1995	Murayama et al.	361	528		
	5,448,447	09/05/1995	Hongju Chang	361	528		
	5,560,761	10/01/1996	Hiroo Naito	75	255		
	5,605,561	02/25/1997	Iwabuchi et al.	75	364		
	5,825,611	10/20/1998	Pozdeev	361	503		
	6,051,044	04/18/2000	Fife	75	229		
	6,115,235	09/05/2000	Naito	361	303		
	6,136,062	10/24/2000	Loffelholz et al.	75	369		
	6,171,363 B1	01/09/2001	Shekhter et al.	75	369		
	6,185,090 B1	02/06/2001	Pozdeev-Freeman	361	524		
	6,193,779 B1	02/27/2001	Reichert et al.	75	343		
	6,212,065 B1	04/03/2001	Pozdeev-Freeman et al.	367	528		
	6,215,652 B1	04/10/2001	Yoshida et al.	631	524		
		6,423,110	07-2002	Natio et al.	75	232	
	<b>FOREIGN PATENT DOCUMENTS</b>						
		Document Number	Date	Country	Class	Sub Class	Translation Yes or No

	DE 19831280	01/20/2000	GERMANY			ABSTRACT
	EP 0 282 291 A2	09/14/1988	EUROPE			
	EP 0 402 687 B1	12/19/1990	EUROPE			ABSTRACT
	EP 0 665 302 A2	08/02/1995	EUROPE			
	EP 0 953 847 A1	11/03/1999	EUROPE			ABSTRACT
	EP 0 984 469 A2	03/08/2000	EUROPE			
	EP 0 984 470 A2	03/08/2000	EUROPE			
	WO 00/08662 A1	02/17/2000	WIPO			Full English Translated Version
	WO 00/49633	08/24/2000	WIPO			ABSTRACT
	WO 01/06525	01/25/2001	WIPO			ABSTRACT
	WO 01/12364	02/22/2001	WIPO			ABSTRACT
	WO 01/64374 A2	09/07/2001	WIPO			
	WO 98/37249 A1	08/27/1998	WIPO			Full English Translated Version
	WO 99/57739	11/11/1999	WIPO			
	WO 99/61184	12/02/1999	WIPO			
	WO 00/36617 A1	06/22/2000	JAPAN			Full English Translated Version
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>						
	Terrance B. Tripp, Malcolm D. Shaw, and Bonnie Cox, "The Effects of Nitrogen on The Properties of Anodic Oxide Films on Tantalum," Pages 317-32, (No Date).					
	Terrance B. Tripp, Richard M. Creasi, and Bonnie Cox, "Tantalum Nitride: A New Substrate For Solid Electrolyte Capacitors," Pages 256-262, (March 2000).					
	W.A. Seriak, L. Schechter, T.B. Tripp, L.L. Lanin, K. Reichert, O. Thomas, and J. Vieregge, "A New Material for Capacitors: Niobium," Pages 82-85, (March 2000).					
	International Search Report for PCT/US 01/06449, mailed on September 13, 2001.					
Examiner			Date Considered			
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					
Form PTO 1449			Patent and Trademark Office - U.S. Department of Commerce			